



Attorney Docket No. SEL 119

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Masayuki HIGUCHI et al

Serial No.: 09/198,751

Filed: November 24, 1998

Art Unit: 2871

Examiner: Minh Toan T. Ton

For: ELECTROOPTICAL DEVICE, METHOD OF
MANUFACTURING THE SAME, AND
ELECTRONIC EQUIPMENT

)
) I hereby certify that this correspondence
) is being deposited with the United States
) Postal Service as first class mail in an
) envelope addressed to:
) Commissioner for Patents, P.O. Box 1450,
) Alexandria, VA 22313-1450, on February 20,
) 2004

) Cristie M. Hall
)

) Date: February 20, 2004
)

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, as revised on February 4, 1992, 1135 OG 23-24, Applicant hereby calls the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. Copies of the references are enclosed herewith for the Examiner's consideration.

The family of JP 02-503360 cited herein includes:
WO Patent no. WO 88/08552

The family of JP 04-362918 cited herein includes:
US Patent no. 5,270,846

The family of JP 05-297364 cited herein includes:
US Patent no. 5,354,497

The family of JP 06-160812 cited herein includes:
US Patent no. 5,541,747

The family of JP 06-160824 cited herein includes:

US Patent no. 5,473,450

JP Patent no. 06-214218

JP Patent no. 06-301015

The family of JP 06-186533 cited herein includes:

US Patent no. 5,638,194

The family of JP 06-331948 cited herein includes:

US Patent no. 5,490,001

US Patent no. 5,546,208

US Patent no. 5,739,882

The family of JP 06-347807 cited herein includes:

US Patent no. 5,552,913

The family of JP 07-013143 cited herein includes:

US Patent no. 5,389,297

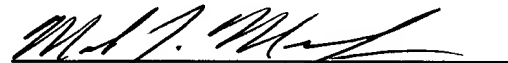
No inference should be drawn that the attached list sets forth a comprehensive investigation of the prior art, that any or all are pertinent to the invention, or that any apparatus disclosed is equivalent to the subject invention.

The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

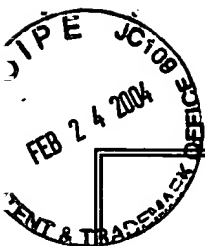
As a RCE is being filed herewith no fee is believed necessary. If a fee is required, please charge Deposit Account No. 50/1039.

Respectfully submitted,



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Registration No.: 34,225

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LIST OF PUBLICATIONS CITED BY APPLICANT			<u>Atty Docket No.</u> SEL 119	<u>Serial No.</u> 09/198,751		
			<u>Applicant</u> Masayuki HIGUCHI et al			
			<u>Filing Date</u> November 24, 1998	<u>Group</u> 2871		
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	3,982,820	09/28/76	Hattori et al	350	160	08/26/75
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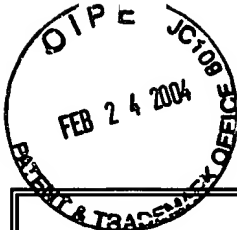
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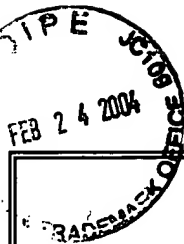
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2) SHIMIZU, M. et al, "Characteristic of a Novel Liquid Crystal Cell with Mixture of FLC and U.V. Curable Resin," MOL. Cryst. Liq. Cryst., vol. 263, pp. 585-587, January 1, (1995).

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*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.



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